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Application No.: 10/728,135

Docket No.: JCLA12578

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Examiner: Chacko Davis, Daborah

Group Art Unit: 1756

In re PATENT APPLICATION of
Applicants : Vencent Chang et al.

Serial No. : 10/728,135

Filed : December 03, 2003

For : IMMERSION LITHOGRAPHY PROCESS
AND MASK LAYER STRUCTURE
APPLIED IN THE SAMEAMENDMENTAMENDMENT AND RESPONSE TO OFFICE ACTIONMail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

The Office Action mailed July 20, 2006 has been carefully considered. In response thereto, please consider the following amendment and remarks.

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